

## PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1  
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EPAS ID: PAT3599076

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
MICHIGAN STATE UNIVERSITY	10/22/2015
<b>RECEIVING PARTY DATA</b>	
<b>Name:</b>	National Science Foundation
<b>Street Address:</b>	4201 Wilson Blvd
<b>Internal Address:</b>	Room 1265
<b>City:</b>	Arlington
<b>State/Country:</b>	VIRGINIA
<b>Postal Code:</b>	22230
<b>PROPERTY NUMBERS Total: 1</b>	
<b>Property Type</b>	<b>Number</b>
Application Number:	12809481
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<b>Total Attachments: 1</b> source=1703#page1.tif	

License to the United States Government

TEC2008-0028-01US

Sign and submit the executed document to the appropriate funding agency (e.g. upload in iEdison).

Invention Title: Direct Ultrashort Laser System

Inventor(s): Vadim V Lozovoy, Bingwei Yu, Marcos Dantus

U.S. Filing/Issue Date: 06/18/2010

Patent or Application Serial No.: 12/809,481

Grant/Contract Number(s): CR0421047

Foreign Applications filed/intended in (countries): GERMANY, UNITED KINGDOM, FRANCE

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above identified grant or contract award from the United States Government. This document is confirmatory of:

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Signed this 22<sup>nd</sup> day of October, 2015.

By Richard W. Chylla (Institutional Business Official) [Signature] (Signature)

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